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10/054884

01/25/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10054884	01/25/2002	445	6	2879	Ramsey

**APPLICANTS: Minami Masato; Iwaki Takashi;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A DIV OF 09/388,427 09/02/1999

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 283659/1998 10/06/1998

JAPAN 217950/1999 07/30/1999

JAPAN 253039/1998 09/07/1998

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		03560 002446.1
Verified and Acknowledged Examiners's initials		
TITLE : Method for manufacturing cathode, electron source, and image forming apparatus		

U.S. DEPT. OF COMM. (PAT. & TM.) PTO-436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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